

FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional) 81872.0124	Application Number 10/597,514
	Applicant Youhei SAKAI, et al.	
	Filing Date July 27, 2006	Group Art Unit 1725

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

	Takeshi SAITO, et al. "A New Directional Solidification Technique for Polycrystalline Solar Grade Silicon" 15 th Photovoltaic Specialist Conference 1981, pp. 576-580

EXAMINER /Seyed Masoud Malekzadeh/	DATE CONSIDERED 03/03/2009
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	